

FOR PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT <small>(Use several sheets if necessary)</small>		ATTY. DOCKET NO. 3521.181	SERIAL NO. 10/674,106
		APPLICANT SOMIT TALWAR, et al.	
		FILING DATE September 29, 2003	GROUP 2813

REFERENCE SIGNATION		U.S. PATENT DOCUMENTS											
EXAMINER INITIAL		DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TN ↓	A	4	3	5	6	3	7	5	10-26-82	Josephy, et al.	219	121 LH	
	B	4	7	3	4	9	1	2	3-29-88	Socrbak, et al.	372	27	
	C	4	7	6	1	7	8	6	8-2-88	Bacr	372	10	
	D	4	9	0	8	4	9	3	3-13-90	Susemuhl	219	121.67	
	E	5	0	5	7	6	6	4	10-15-91	Johnson, et al.	219	121.69	
	F	6	2	0	8	6	7	3	3-27-01	Miyake	372	22	
	G	6	3	6	6	3	0	8	4-2-02	Hawryluk, et al.	347	256	
	H	6	7	4	7	2	4	5	6-8-04	Talwar, et al.	219	121.8	

FOREIGN PATENT DOCUMENTS														
		DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
													YES	NO

OTHER		ART (Including Author, Title, Date, Pertinent Pages, Etc.)
TN	I	Naem, Boothroyd, Calder, <i>CW Laser Annealed Small-Geometry NMOS Transistors</i> , Mat. Res. Soc. Symp. Proc. Vol. 23 (1984) pp 229-234.
TN	J	Goetzlich, Tsien, Ryssel, <i>Relaxation Behavior of Metastable AS and P Concentrations in SI After Pulsed and CW Laser Annealing</i> , Mat. Res. Soc. Symp. Proc. Vol. 23 (1984) pp 235-240

EXAMINER T. N. BRULLEN	DATE CONSIDERED 12/28/05
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.